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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stefan BADER et al.

Serial No.: 10/671,854

Filed: September 25, 2003

For: Electromagnetic Radiation Emitting  
Semiconductor Chip and Procedure for its  
Production

Examiner: TRAN, Minh Loan  
Group Art: 2826

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Name of applicant, assignee or Registered Representative

*Thomas Langer*  
Signature

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AMENDMENT AFTER FINAL REJECTION

SIR:

RESPONSE

In response to the Final Office Action dated February 24, 2006, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.